



[14, Fig. 1], which implements a feedback loop counteracting moderate disturbances, thereby ensuring a certain stability and noise immunity.

One can find a many ULP applications, especially biomedical [16], [17], for which the activity factor of the SRAM is low so that the typical retention time is long. This makes the retention mode all the more critical in terms of energy minimisation and dynamic stability. From a power-aware design point of view, the key issue is to further reduce  $V_{DD}$  in retention (lower than for the read/write operations [16], [17]), while maintaining the cell failure probability below an acceptable value.

Simulating failures in retention, i.e. bit flips induced by the intrinsic noise of the transistors, requires computational intensive transient noise analyses [7], [8], [9], [18]. Those are conventional time-domain simulations however with independent random current noise sources added in parallel to each dissipative devices (resistors, MOS transistors,...). A robust methodology, compatible with industrial tools, was described in [7]. Whereas transient noise simulations are suitable and insightful (as emulating real-world conditions) for nonlinear circuits operating in out-of-equilibrium, large-signal conditions such as SRAM bitcells on the verge of instability, the CPU time quickly explodes with the number of cases (e.g. process variations) [7], [8], [9]. The brute-force approach that couples Monte-Carlo simulations with transient noise analyses is therefore prohibitively expensive. This has motivated former attempts of faster prediction methods. The authors of [18] and [19] developed an accelerated simulator aimed at efficiently estimating the *mean time to failure* (*MTTF*) in CMOS latches though not straightforward to extend to other memory architectures and technologies. We also find a few analytical attempts in the literature. The framework proposed in [20] and [21], based on Markov chains and queue theory, suffers from the same limitations as [18] and [19] and lacks validation with SPICE transient noise simulations. In [22], the *MTTF* is calculated from stochastic thermodynamic considerations, however assuming simplified transistor model and constant capacitances. We owe the only existing closed-form formula in the electronics literature to Kish [23], with preliminary attempts of application reported in [8] and [24]. The previous works [8], [9], [25] have nevertheless shown by numerical experiments that Kish's and the similar but more rigorous Nobile's formulas [26] lack accuracy. Both indeed rely on a coarse near-steady-state approximation around the presumed stable point of the bitcell in retention, which is highly inappropriate in describing the stochastic nonlinear dynamics of the SRAM [25] as will be further revisited in the present paper.

Very recently, an extended Eyring-Kramers formula has been derived from stochastic calculus [25]. Relying on a unidimensional stochastic model fully characterizable with SPICE simulations [9], it does account for both the nonlinear SRAM dynamics and the varying noise intensity along the bit-flip trajectory. Remarkable in terms of accuracy, the formula aims at predicting the mean transition time in a wide and general class of autonomous nonlinear bistable systems, in particular the *MTTF* in SRAM bitcell in retention. Combined with the process variability-aware framework introduced in [8],

we believe that such a semi-analytical approach is a promising avenue for efficient SPICE-compliant reliability assessment.

Extending the proceedings [8], [9], we thus propose a methodology for fast and accurate prediction of the *MTTF* in ULV SRAM bitcells in retention, in presence of both process variations and intrinsic noise. The rest of this paper is structured as follows. Section II present the process variability-aware simulation framework of [8] in order to insightfully identify the worst-cases of endangered functionality. Transient noise simulations is then the purpose of Section III. Starting from the observation, the bit-flip mechanism is extensively explained in Section III-A. The choice of the simulation parameters and the related CPU time are addressed in Section III-B. In Section III-C, we analyse and model the *TTF* distribution to show that, in agreement with the general theory of Markovian bistable system, the *MTTF* metric alone fully parametrises it and hence is relevant in quantifying the SRAM dynamic stability. Stochastic modeling is extensively developed in Section IV, first generally (Section IV-A) and then formally reduced to unidimensional dynamics (Section IV-B) as conjectured in [9]. We place particular emphasis on the characterisation from conventional deterministic SPICE simulations, compatible with industrial transistor compact models and advanced technologies. Subsequently, approximate closed-form formulas to predict the *MTTF*, valid when the thermal noise is dominant, are summarised in Section V. Their accuracies are discussed in Section VI, dedicated to the results. Section VII finally draws the conclusions and opens perspectives regarding the future incorporation of the low-frequency noise, in addition to process variations and thermal noise.

## II. PROCESS VARIABILITY-AWARE SIMULATION FRAMEWORK

The voltage limit in ULV circuits is mainly dictated by process variations [2, Fig. 17]. As extensively reviewed in [6], enhanced Monte Carlo methods rely on the most recent advances in importance sampling to speed up the simulations whose aim is to empirically estimate the SRAM failure probability. The intrinsic noise of the transistors (including the access transistors  $M_5$  and  $M_6$  shown Figure 1) and of peripheral circuits comes as an additional uncertainty, taking on the design margins. The same goes for the supply-voltage (droop) noise. The  $V_{DD}$  referred to as below may therefore be thought as the minimal supply voltage, reduced compared to its nominal value.

In [6], a novel non-Monte-Carlo semi-analytical methodology was introduced the detect the hold failures caused by static variability within ULV SRAM bitcells. It was shown that the dominant effect of process variations affecting the MOS transistors can be suitably and accurately modelled by two series-voltage sources  $\delta V_1$  and  $\delta V_2$ , each applied at the input of one inverter of the latch [6, Figure 4]. The noise margin of a CMOS inverter operating in subthreshold is indeed dominantly degraded by the imbalance between nMOS and pMOS transistors [2], [27]. These  $\delta V$  may notably be related to the individual  $V_{th}$  shifts and the same goes for their statistics [6]. This is why we understand these sources of variations

as “intrinsic” to the physical inverters: for instance, “Inverter 1” refers to a nominal inverter affected by  $\delta V_1$  (see dashed box in Figure 2(a)) throughout the text. Their effect is incorporated in the *modified* voltage transfer characteristics (VTCs), shifted from the nominal VTCs (in green in Figure 2(c)). The double DC sweep of the variations ( $\delta V_1, \delta V_2$ ) yields the two-dimensional (2D) representation of Figure 2(b). To each ( $\delta V_1, \delta V_2$ ) point is thoughtfully associated an SRAM bitcell, whose functionality has been assessed with the traditional “butterfly plot” [28] (Figure 2(c)). A tested bitcell is functional (green and orange), at time zero, if the number of cross points is exactly equal to three; defective (red) otherwise. The (positive) *static noise margin* (*SNM*) of the functional bitcells can be extracted with the SPICE-compliant method from List and Seevinck [28]. The procedure is graphically illustrated for three special cases of variations in Figure 2(c): nominal bitcell ( $SNM = 61$  mV, comfortably stable),  $\delta V_1 = -\delta V_2 = 55$  mV ( $SNM = 5$  mV, barely functional), 65 mV (defective).

Whereas any SRAM bitcell exhibiting a non-negative noise margin ( $SNM \geq 0$ ) would be classified as functional based on purely static considerations, we expect those with lowest *SNM* to have poor noise immunity and to be dynamically *unstable*. Rigorously, the *SNM* only quantifies the robustness of a bitcell against DC sources of variations, in a particular scenario where both inverters are adversely affected [6] (dashed line  $\delta V_1 = -\delta V_2$ ). The dynamic noise margin, i.e. the robustness of the bitcell against transient noise, is substantially larger than the *SNM* as a consequence of the non-zero response time of the inverter gates (low-pass filtering effect) [7], [29]. The *SNM* nevertheless remains an indicative metric of low noise immunity and we can identify cells to be treated in priority for noise analysis.

In Figure 2(b), we have highlighted in orange the region corresponding to bitcells whose *SNM* lies between 0 (verge of instability, corresponding to the failure boundary shown in black dots) and 10 mV. Crucially, short *TTF* [18], [24] are likely observed for the bitcells in the orange crown, possibly shorter than the typical retention time of the memory application and hence unacceptable. The intrinsic noise therefore inflates the cell failure probability, in addition to variability, and one wants to assess its contribution through the probability

$$P(TTF < \text{retention time} \mid SNM \geq 0). \quad (1)$$

whereas the inner boundary of the orange crown of Figure 2(b) is firstly guessed by  $SNM \leq 10$  mV, an iterative procedure would ultimately compare the obtained *TTF* to the retention time to enlarge the statistically relevant area. The whole area should be covered for a sound calculation of (1) in a longer-term reliability perspective. The naive approach would rely on repeated trials of transient noise simulations, in a Monte-Carlo fashion. As will be evidenced in the next Section III, this route is totally unaffordable without accelerated framework.

### III. TRANSIENT NOISE SIMULATIONS

Simulating the noise in the time domain requires to: (i) add individual physical noise sources in parallel with each device

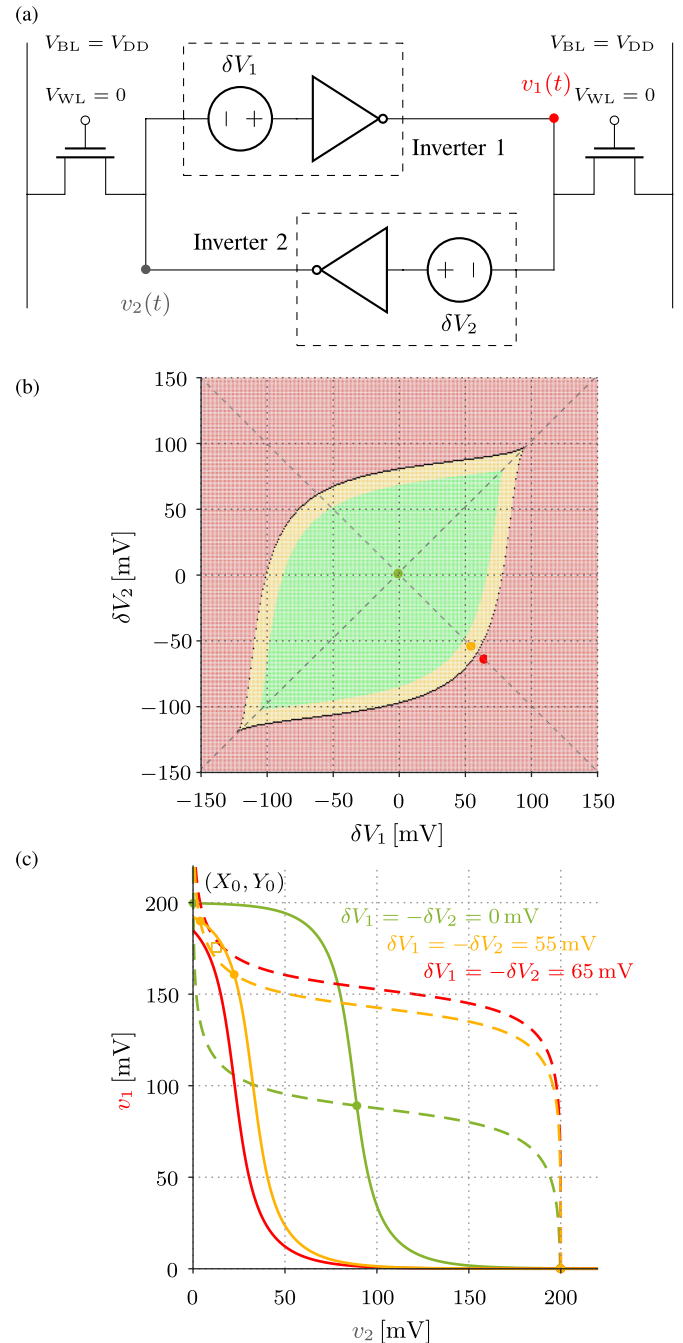


Fig. 2. (a) SRAM bitcell in retention mode, with process variations modelled as series-voltage sources applied at the inputs of the two inverters ( $M_1$  and  $M_2$ ,  $M_3$  and  $M_4$  in Figure 1). (b) 2D representation of functional (green and orange) and defective (red) SRAM bitcells in presence of process variability, deterministically simulated with a double DC sweep of variations ( $\delta V_1, \delta V_2$ ). The orange crown contains the bitcells of positive but low *SNM* ( $\leq 10$  mV). Voltage step of the double DC sweep:  $\Delta\delta V = 1$  mV. (c) Butterfly plots of three special cases marked by dots in (b), along the line  $\delta V_1 = -\delta V_2$  corresponding to the worse-case scenario where both inverters are adversely affected. For functional bitcells, the *SNM* is the width of the largest inscribed square. Illustrated case: 28 nm FD-SOI Single-P-Well (SPW) SRAM cell (inverters made of RVT nMOS and LVT pMOS; RVT nMOS access transistors) of minimal transistor dimensions  $L_n = L_p = 30$  nm and  $W_n = W_p = 80$  nm, SPW bias  $V_B = 0$ , operating at  $V_{DD} = 200$  mV and  $T = 300$  K.

(e.g. transistor); (ii) generate random values at each time step; (iii) perform conventional transient simulations [7].

While insightful and accurate as emulating real-world large-signal conditions for arbitrary nonlinear circuits [30], transient noise analyses are rarely encountered in the literature. The first reason is, undoubtedly, the high computation time, difficult to fit in a design schedule; the second is, possibly, a lack of understanding of the specific simulation parameters. These points will be addressed in Section III-B.

The concern is further reinforced by an additional challenge: the incorporation of process variability in noise analyses, or conversely. The rarity of the failure events makes the brute-force approach coupling Monte-Carlo simulations with transient noise simulations even more prohibitively expensive. Previous work [7] mainly focused on symmetrical latches (neglecting access transistors  $M_5$  and  $M_6$  in Figure 1) operating at extremely low  $V_{DD}$ , however in the somewhat artificial situation of zero process variations. Provided with home-made accelerated noise simulation tools, the authors of [18], [20], and [21] introduced variability as a global deterministic imbalance between nMOS and pMOS transistors (asymmetrical process corner), like [24]). Instead, we rely on the framework presented in Section II, according to which we leverage on Figure 2(b) to select the weakest SRAM bitcells prone to dynamic instability.

Because of the CPU-time constraint, we have focused the transient noise analyses on a few limit cases belonging to the worst-case line  $\delta V_1 = -\delta V_2$  (dashed line in Figure 2(b)); the case 55 mV presented earlier in orange in Figure 2(c) is one of them. From statistical considerations involving a two-dimensional Gaussian variability distribution [6], we can show that such selected points lie within a 10 ppm-equiprobability circle [6], i.e. frequently encountered among Monte-Carlo samples or fabricated bitcells. The choice  $\delta V_1 = -\delta V_2$  does not affect the generality of the presented methodology and subsequent analyses. We emphasize that, whereas we first *observe* the bit-flip mechanism in the time domain, the expensive transient noise simulations are *not* part of the proposed predictive methodology.

The two output node voltages are denoted  $v_1(t)$  and  $v_2(t)$  (Figure 2(a)), respectively. The role of the two cross-coupled inverters of Figure 2(a) is totally interchangeable. Having adopted the convention  $\delta V_1 = -\delta V_2 > 0$ , the endangered memory state is  $(v_2, v_1) = (X_0, Y_0)$  (see Figure 2). The exact high and low logic levels  $X_0$  and  $Y_0$  depend on the process variations affecting the particular bitcell (see again Figure 2). We have used the right initial data  $(v_2(0), v_1(0)) = (X_0, Y_0)$  as the initial condition for all the transient experiments of the retention operation (i.e. not the approximate  $(0, V_{DD})$  as [8], which resulted in a short settling time of about 1  $\mu$ s to reach the actual steady state).

#### A. Observation and Analysis of the Bit-Flip Mechanism

One typical transient simulation of a bit-flip caused by intrinsic transistor noise is shown in Figure 3(a) [8]. The bit-flip mechanism in SRAM bitcells is better understood within the mathematical formalism of nonlinear dynamical systems [31], [32]. We call *state vectors* the pairs of voltages  $(v_2(t), v_1(t))$ . The set of all the possible values of those

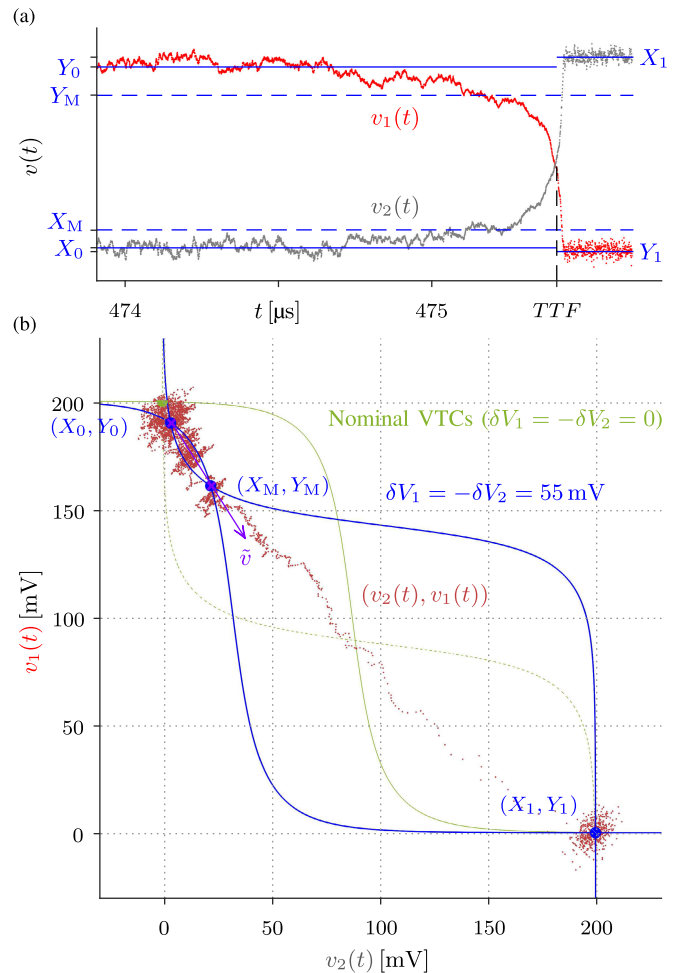


Fig. 3. (a) Transient simulation of a noise-induced bit flip (failure) in the 6T SRAM bitcell in retention (Figure 2(a)). Adapted from [9]. (b) State trajectory of the bit flip of (a) in the state space. The nominal and modified VTCs of the inverters are shown in blue and green, respectively. The unidimensional reaction coordinate  $\tilde{v}$  is shown in violet. Illustrated case: same SRAM design as Figure 2, with process variations  $\delta V_1 = -\delta V_2 = 55$  mV [9]. Bandwidth of the generated noise:  $f_{\max} = 1$  GHz ( $\Delta t = 500$  ps) [8].

vectors forms the *state space* [31]. The *state trajectory*, obtained by plotting the state vectors at various times in the state space, is depicted in Figure 3(b). The butterfly of the affected SRAM bitcell is also represented in the state space in order to locate the two stable steady states or points  $(X_0, Y_0)$  and  $(X_1, Y_1)$ , which slightly deviate from the nominal and ideal  $(0, V_{DD})$  and  $(V_{DD}, 0)$  due to process variations  $\delta V_1$  and  $\delta V_2$ , and to emphasize the out-of-equilibrium behavior of the system during the transient bit flip. To each stable state is associated a *stability region* or *region of attraction* [32]. The *stability boundary*, or *separatrix* [32], which separates the two stability regions, necessarily includes the saddle (*unstable*) point  $(X_M, Y_M)$ .

At the beginning of the represented time segment, the two node voltages  $v_2(t)$  and  $v_1(t)$  (defined in Figure 2(a)) fluctuate quietly around the logic levels  $X_0$  and  $Y_0$ , the data initially retained by the SRAM bitcell. Starting from about 474.5  $\mu$ s,  $v_2(t)$  gradually increases and  $v_1(t)$  decreases due to hazardous and simultaneous large voltage noise fluctuations. This process goes against the deterministic regenerative property of the

inverters, which in absence of continuous disturbance would restore the logic levels  $X_0$  and  $Y_0$ . Once  $v_2(t)$  and  $v_1(t)$  have crossed specific thresholds, respectively  $X_M$  and  $Y_M$  (Figure 3(a)), i.e.  $(v_2(t), v_1(t))$  has gone beyond the unstable steady state  $(X_M, Y_M)$  and thereby has crossed the separatrix (Figure 3(b)), the two cross-coupled inverters enter in positive feedback loop.  $(v_2(t), v_1(t))$  falls in the region of attraction of the other stable steady state,  $(X_1, Y_1)$ , the bit flip becomes highly likely and rapid as dictated by the natural dynamics of the SRAM bitcell. The positive feedback makes the node voltages vary almost exponentially [31] as we can observe in Figure 3(a). This mode has sometimes been referred to as “strong feedback mode” [31].

Formally, the  $TTF$  is the time taken by the state to cross the separatrix for the last time, when the transition from  $(X_0, Y_0)$  to  $(X_1, Y_1)$  is completed. Experimentally, we define the completion of the state flip and we record the  $TTF$  when  $v_2(t)$  and  $v_1(t)$  cross, corresponding to the logical switch  $0 \rightarrow 1$ ; it can be noticed in Figure 3(a) that, at this stage, crossing backward becomes unlikely due to the asymmetry of the bitcell. Because of the fast exponential evolution of the voltages beyond  $(X_M, Y_M)$ , the two definitions are consistent. This  $TTF$  is a random variable for a given bitcell, which takes a different value for each experiment carried out.

Although determining the exact shape of the full separatrix (as addressed in [32]) is not required in this work, it is important to understand that  $(X_M, Y_M)$  is the threshold point. If we assume, after observation of Figure 3 (other trajectories simulated for other cases behaved similarly), that a bit flip occurs according to the preferential direction given by the line connecting the two nearby points  $(X_0, Y_0)$  and  $(X_M, Y_M)$ , the necessary failure criterion is that  $v_2(t)$  and  $v_1(t)$  cross the thresholds  $X_M$  and  $Y_M$ , respectively. The largest the individual distances  $\Delta X \equiv X_M - X_0$  and  $\Delta Y \equiv Y_1 - Y_M$ , the statistically rarest the bit-flip event (at fixed noise intensity) and the most robust the SRAM bitcell is. The deleterious effect of process variability is to reduce the noise margins (like the  $SNM$ ) and, similarly,  $\Delta X$  and  $\Delta Y$ . This leads to short  $TTF$ . The relevance of this hypothesis of unidimensional dynamics in estimating the  $TTF$ , here phenomenologically observed, will be further formalized and quantitatively justified in Section IV.

### B. Simulation Parameters and CPU Time

Careful setting of the transient simulations parameters like the generated noise bandwidth ( $f_{\max}$ ), time step ( $\Delta t$ ), and duration optimizes the CPU-time tradeoff while ensuring accuracy [7]. Preliminary to transient simulations, we have extracted, for each  $(\delta V_1, \delta V_2)$  case studies, the noise bandwidth  $f_p$  of the inverters in the closed-loop configuration of Figure 2(a) (unlike [7] which suggested an open-loop procedure). Such NOISE(AC) simulations and their importance in determining the noise intensities will be described in Section IV. We make several important comments at this stage. First of all, the two inverters may have significantly different bandwidths (typically by a factor  $\approx 2$ ), because the input of one is low ( $X_0$ , close to 0) while the input of the other is high ( $Y_0$ , close to  $V_{DD}$ ). Secondly, the bandwidth decreases from

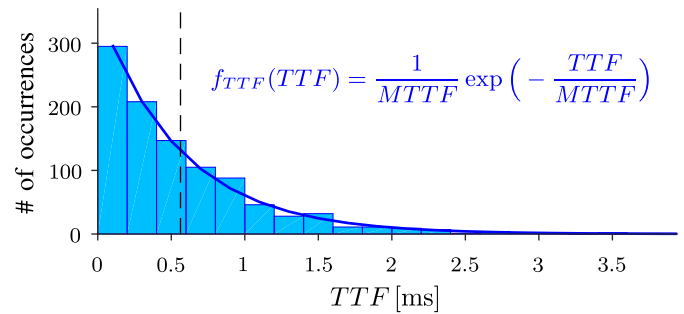


Fig. 4. Empirical histogram of the  $TTF$ , constructed from 1000  $TTF$  realisations of transient noise simulations like Figure 3. The  $MTTF \approx 0.56$  ms is indicated by the vertical dashed line. Solid line represents the theoretical exponential distribution (2) with the empirical sample mean plugged into it. Illustrated case: same as Figure 3. The bin width of 0.2 ms was chosen for illustration but is not directly related to any simulation parameter.

about 100 MHz for the bitcell free of any process variation down to a only few MHz for the largest  $\delta V_1 = -\delta V_2$ .

In order to take into account all contributing noise components, we usually use as generated noise bandwidth  $f_{\max} \approx 10 \cdot f_p$  [7]. The  $f_{\max} = 1$  GHz used in [8] is thus an excessively loose choice, computationally inefficient. To better optimise the CPU-time tradeoff [7], we here use  $f_{\max} = 50$  MHz. The maximum time step of the transient simulation ( $\Delta t$ ) is related to  $f_{\max}$  through  $\Delta t = 1/(2 f_{\max})$  [7].

Setting the appropriate duration of the transient simulation is difficult for a highly asymmetrical bitcell, because the typically measured  $TTF$  are not known and hardly guessed *a priori*. As shown in previous work [7] and as will be illustrated in Section VI, the  $MTTF$  metric evolves across several orders of magnitude with  $SNM$  variations of a few mV. With the aim of being able to observe longer  $TTF$ , corresponding to the right tail of the  $TTF$  distribution [18] (also studied in the next Section III-C), we ideally want the duration to exceed at least  $10 \cdot MTTF$ , approximately. This may require an iteratively refined simulation plan. In practice and since we focus on the shortest  $MTTF$  cases, we limit and set the duration of all the transient experiments to 5 ms. Finally, let us mention that, for each  $(\delta V_1, \delta V_2)$ , we must perform 1000 repeated experiments and record a bit flip occurring at a random  $TTF$  for each of them, to guarantee the statistical accuracy of the empirical  $MTTF$  estimator (relative standard error of the mean is 3%).

Let us mention that, despite this finely optimised set of parameters, we still end up with a huge CPU time of a few hours per single bit-flip experiments and of three days to go through four selected  $\delta V_1 = -\delta V_2$  variability cases. This, despite the use of a high-performance work station and parallel multi-core computing. Though, the whole orange crown of Figure 2(b) should be covered by massive transient noise simulations in order to estimate all the  $MTTF$  and to evaluate (1). Without accelerator or semi-analytical framework, this would take several weeks or months of computation, prohibiting the naive brute-force approach.

### C. Distribution of the Time to Failure

Using the 1000 recorded realisations for each variability case, we can empirically construct the probability density

function (PDF) of the random variable  $TTF$  as an histogram (depicted in Figure 4). In agreement with the theory of Markovian bistable system [33], the distribution is found to be exponential:

$$f_{TTF}(TTF) = \frac{1}{MTTF} \exp\left(-\frac{TTF}{MTTF}\right), \quad (2)$$

like [19, Fig. 11]. The authors of [18, Fig. 6] found, instead, a log-normal distribution. This could be an artefact of their iterative threshold-crossing algorithm, according to [19].

Importantly, the theoretical PDF (2) is entirely characterized by one single parameter: the mean, i.e. the  $MTTF$  whose estimation is the purpose of the present paper. Within the usual notations in probability theory,  $\lambda = 1/MTTF$  [33]. In particular, the standard deviation of the  $TTF$  is nothing but the  $MTTF$  too. Thus, the  $MTTF$  alone contains all the information about the statistics of the noise-induced failures, which are rare events. For a given  $MTTF$  (e.g. the process variations are known and fixed), the probability (1) can be explicitly evaluated from (2):

$$P(TTF < \text{retention time}) = 1 - \exp\left(-\frac{\text{retention time}}{MTTF}\right). \quad (3)$$

Equation (3) clearly highlights the relevance of the  $MTTF$  metric, compared to the typical retention time of the SRAM. The left tail of the  $TTF$  distribution corresponds to the shortest  $MTTF$ , unacceptable when smaller than the retention time, as (3) quantifies in probability.

This said, we emphasize that the demanding part of the reliability analysis is the estimation of the  $MTTF$ , for some given process variations  $(\delta V_1, \delta V_2)$  selected from Figure 2(b), to be eventually plugged into (2) or (3). Subtly,  $MTTF$  varies from one bitcell to another due to process variations and hence should be itself thought as a random variable within a sample space made of a large number of bitcells.

#### IV. STOCHASTIC NONLINEAR DYNAMICAL MODELING

An SRAM bitcell in retention is undriven, i.e. isolated from peripheral circuitry (except for the leakage currents through the access transistors, which are taken into account in our study). It can therefore, generally, be assimilated to an autonomous stochastic nonlinear dynamical system, whose modeling is the purpose of this section.

##### A. Two-Dimensional Stochastic State-Space Model

1) *Nodal Analysis of the SRAM Bitcell*: We reasonably assume that the state of the system is fully determined by the node voltages  $v_1(t)$  and  $v_2(t)$  (as indicated in Figure 2(a)). The set of coupled nonlinear differential equations governing the dynamics, i.e. the time evolution of  $v_1(t)$  and  $v_2(t)$ , results from the application of Kirchhoff current law at both nodes:

$$\begin{aligned} & \begin{pmatrix} C_{22}(v_2, v_1) & C_{21}(v_2, v_1) \\ C_{12}(v_2, v_1) & C_{11}(v_2, v_1) \end{pmatrix} \begin{pmatrix} dv_2/dt \\ dv_1/dt \end{pmatrix} \\ & = \begin{pmatrix} I_2(v_2, v_1) \\ I_1(v_2, v_1) \end{pmatrix} + \begin{pmatrix} i_{n,2}(t) \\ i_{n,1}(t) \end{pmatrix}. \end{aligned} \quad (4)$$

The stochastic differential algebraic equation (4) is understood in Itô' sense, consistently with [25]. The importance and the relevance of this convention is discussed in more detail below.

The general model (4) can be obtained from a modified nodal analysis of the circuit of Figure 2(a), taking into account the intrinsic capacitances and the random noise sources of the MOS transistors.  $I_2(v_2, v_1)$  denotes the static component of the current flowing out of Inverter 2, a nonlinear function of  $v_2$  and  $v_1$  through the  $v_{GS}$  and  $v_{DS}$  of the MOS transistors. It also incorporates the contribution of the leakage of the access transistor.

All the dynamic currents of the transistors have been regrouped in the form  $C_{ij} dv_j/dt$ , as included in the left side of (4). For instance,  $C_{22}$  may be thought as the sum of the output capacitance of Inverter 2 and the input capacitance of Inverter 1 referred to the ground. The capacitive coupling between input and output of each inverter comes from the gate-to-drain capacitances of the transistors, embedded in  $C_{12}$  and  $C_{21}$ . Most generally, all the intrinsic capacitances depend on the instantaneous voltages and are nonlinear. Extracting them from SPICE simulations is neither trivial nor practical, nor even useful for our purposes as will be explained below. It is, however, important to recognise the role of the capacitive currents in determining SRAM bitcell dynamics by relating the voltage variations to currents.

The noise is intrinsic to all the transistors (including the access). In (4), all the individual noise contributions are collected into single parallel-current sources  $i_{n,2}(t)$  and  $i_{n,1}(t)$ . The white thermal noise intensities (i.e. the variances of  $i_{n,2}(t)$  and  $i_{n,1}(t)$ ) do vary with  $(v_2, v_1)$  in general, because the MOS transistors are nonlinear dissipative devices [34].

In former work [31, eq. (2)-(3)], single constant output node capacitance was assumed:  $C_{22} = C_{11} = C = \text{constant}$ , together with  $C_{21} = C_{12} = 0$ . Subsequently simplified and inaccurate analytical transistor and inverter models were used. Moreover, only deterministic pulse noise were considered as disturbance  $i_n(t)$  in [31], inappropriate in modeling the thermal noise. The accelerated thermal noise simulator of [18] and [19] assume constant  $C_{ij}$ . In the present work, we instead rely on a general reformulation of (4) as a *stochastic state-space representation*, characterizable without approximation from conventional SPICE simulations.

2) *State-Space Representation*: Equation (4) can be compactly rewritten in matrix form:

$$\mathbf{C}(\mathbf{v}) \frac{d\mathbf{v}}{dt} = \mathbf{I}(\mathbf{v}) + \mathbf{i}_n(t) \quad (5)$$

denoting  $\mathbf{v} = (v_2, v_1)^T$ . The matrix  $\mathbf{C}$  is diagonally dominant because the load capacitances  $C_{22}$  and  $C_{11}$  are substantially larger than the coupling capacitances  $C_{21}$  and  $C_{12}$ . This ensures  $\det \mathbf{C} = C_{22}C_{11} - C_{21}C_{12} > 0$  as  $C_{22}C_{11} \gg C_{21}C_{12}$ , i.e. the matrix  $\mathbf{C}$  is known to be invertible. We may thus formally transform (5) into

$$\begin{aligned} \frac{d\mathbf{v}}{dt} & = \mathbf{C}(\mathbf{v})^{-1} \mathbf{I}(\mathbf{v}) + \mathbf{C}(\mathbf{v})^{-1} \mathbf{i}_n(t) \\ & \equiv \mathbf{h}(\mathbf{v}) + \boldsymbol{\sigma}(\mathbf{v}) \mathbf{w}(t). \end{aligned} \quad (6)$$

We refer to (6) as the (stochastic) state-space representation of the system [25].  $\mathbf{h}(\mathbf{v})$  is a two-dimensional (2D) *drift vector field*, further analyzed here below. The vector  $\mathbf{w}(t) = (w_1(t), w_2(t))$  contains two independent (since generated by different devices) white noises of unit power spectral density (PSD);  $\sigma(\mathbf{v})$  is the square *diffusion matrix*, non-diagonal as a consequence of the capacitive coupling involved in (6) through the  $\mathbf{C}(\mathbf{v})^{-1}$ . The  $\sigma(\mathbf{v})$  matrix will be extensively explained thereafter, at the light of dedicated SPICE extractions.

Mathematically, a continuous-time white noise  $w(t)$  of infinite bandwidth does not rigorously exist, because its variance is infinite. Only the integral of a white noise, i.e. a *Wiener process* (or Brownian noise)  $W(t) = \int_0^t w(t) dt$ , is soundly defined [35]. This is why some authors [25], [36] prefer to adopt the more rigorous notation of *stochastic differential equation* (SDE):  $d\mathbf{v} = \mathbf{h}(\mathbf{v}) dt + \sigma(\mathbf{v}) d\mathbf{W}(t)$ . Written as (6), the stochastic state-space model is a (vectorial) nonlinear *Langevin equation*. It may only be formally interpreted as an SDE by adopting an interpretation rule for stochastic integral calculus [37], such as Itô or Stratonovich's scheme [36]. The question is relevant because the SRAM bitcell exhibits a nonlinear behavior and the noise intensity  $\sigma(\mathbf{v})$ , modulated by the state  $\mathbf{v}$ , is not constant. As widely discussed elsewhere [36], [37], the two formulations imply, for a given physical system, a different function  $\mathbf{h}(\mathbf{v})$  but lead to the *same* solution (statistical distribution of  $\mathbf{v}(t)$ ). Previous works dedicated to electronic circuit modeling [35], [38] suggest, however, that Itô's interpretation follows naturally from conventional formulation like (4) and (6) and is especially consistent with the SPICE implementation of transient noise simulations. Thus, all through this paper, SDE like (6) must be understood in Itô's sense as assumed in [25] when performing stochastic calculus.

3) *SPICE Characterization of the Drift*: If the noise term vanishes in (6), the evolution of  $\mathbf{v}(t)$  is only dictated by the drift field  $\mathbf{h}(\mathbf{v})$ :

$$\frac{d\mathbf{v}}{dt} = \mathbf{h}(\mathbf{v}). \quad (7)$$

The interpretation is that, in the theoretical absence of noise, the state trajectory follows the natural “deterministic” dynamics of the silent cross-coupled inverters. As explained earlier in Section III-A, their regenerative action brings  $(v_2(t), v_1(t))$  to either  $(X_0, Y_0)$  or  $(X_1, Y_1)$  depending on the initial state. Equation (7) provides a straightforward tool to extract  $\mathbf{h}(\mathbf{v})$  from conventional noiseless transient simulations (TRAN in SPICE). For this purpose, we use a uniform grid in the state space of Figure 3(b) as initial conditions. We record the evolutions of the different trajectories  $(v_2(t), v_1(t))$  (Figure 5(a)) and compute the two time derivatives  $dv_2/dt$  and  $dv_1/dt$  numerically (the two scalar components of (7)). A discretised  $\mathbf{h}(\mathbf{v})$  is finally obtained by mapping the vectors  $d\mathbf{v}/dt$  and  $\mathbf{v}(t)$ . It is depicted in Figure 5(b) as a vector field, with a zoom on the region relevant for bit-flip analysis.

Figure 5(a) shows the usual characteristics of a bistable system. The two stable steady states  $(X_0, Y_0)$  or  $(X_1, Y_1)$  attract, from all directions, the trajectories in their respective basin of attraction. The unstable steady state  $(X_M, Y_M)$  exhibits a typical saddle-point behavior [39]. It is *repulsive*

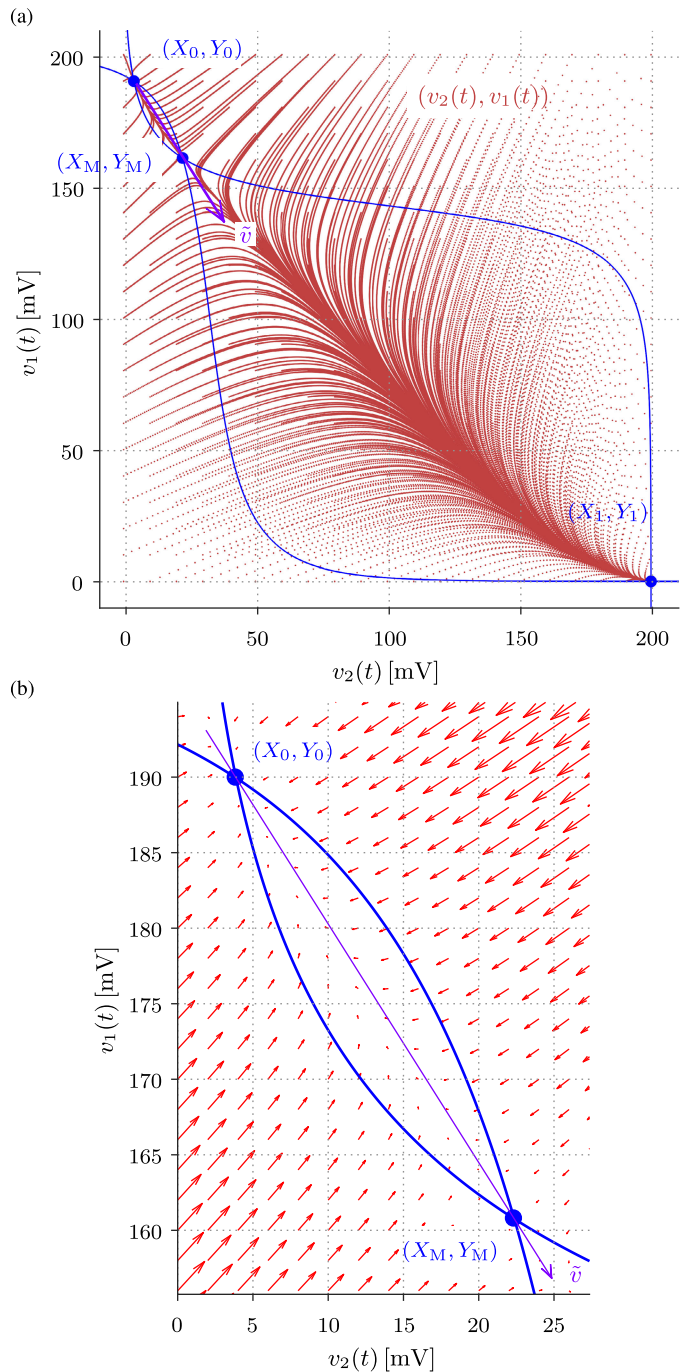


Fig. 5. (a) Simulated deterministic  $(v_2(t), v_1(t))$  trajectories in the state space, starting from uniformly gridded initial conditions. The stable steady states  $(X_0, Y_0)$  and  $(X_1, Y_1)$  (valley points) are attractive. The unstable steady state  $(X_M, Y_M)$  (saddle point) is repulsive along its manifold closely approximated by the straight line parametrised by  $\tilde{v}$  (in violet), and attractive in the orthogonal direction (separatrix). (b) Two-dimensional drift field  $\mathbf{h}$ , with a zoom on the stable steady state  $(X_0, Y_0)$  weakened by process variability. The intensity of  $\mathbf{h}$  (i.e. arrow size) in the orthogonal direction tends to quickly push  $(v_2(t), v_1(t))$  toward the  $\tilde{v}$  axis (shown in violet), which supports the observation of the time-scale separation and the underlying assumption of reduction of dimensionality. Illustrated case: same as Figure 3.

along its *unstable manifold*, which coincides with the *stable manifold* of  $(X_0, Y_0)$ . The *heteroclinic orbit* from  $(X_0, Y_0)$  to  $(X_1, Y_1)$  [40] is roughly the  $\tilde{v}$  straight line connecting them (parametrised by  $\tilde{v}$  in violet in Figure 3(b)). The orbit is,

in the region between  $(X_0, Y_0)$  and  $(X_M, Y_M)$ , contained in the stable manifold of  $(X_0, Y_0)$  and in the unstable manifold of  $(X_M, Y_M)$ . The unstable steady state  $(X_M, Y_M)$  is *attractive* along its stable manifold, corresponding to the more or less straight separatrix [32] in the orthogonal direction.

More specific to the SRAM bitcell and useful for our purposes is the observation of a *time-scale separation*: whatever the exact initial condition, the trajectory rapidly converges, in a very short time, toward the heteroclinic orbit ( $\tilde{v}$  straight line connecting  $(X_0, Y_0)$  and  $(X_M, Y_M)$  in Figures 3(b) and 5(b)). Then, the evolution toward either attractive steady state along this orbit is *slower*.

Those notions of velocity and time are more easily appreciated in Figure 5(b). Outside the wing of the butterfly, the drift vector field points almost perpendicularly toward the  $\tilde{v}$  line, with large arrows translating high velocity and very short time constant. Along the unstable manifold of  $(X_M, Y_M)$ , the tiny arrows show that the unidimensional dynamics in  $\tilde{v}$  is slow and hence is expected to dominate the transition time. It is possible to make those observations more quantitative, at least near the steady states. One may for instance linearize (7) near the stable point  $\mathbf{v}_0$

$$\frac{d\mathbf{v}}{dt} \approx \frac{d\mathbf{h}}{d\mathbf{v}}_{\mathbf{v}=\mathbf{v}_0} (\mathbf{v} - \mathbf{v}_0) \equiv \mathbf{A}(\mathbf{v} - \mathbf{v}_0), \quad (8)$$

since  $\mathbf{h}(\mathbf{v}_0) = \mathbf{0}$  by definition, and to compute the eigendecomposition of the Jacobian matrix  $\mathbf{A}$ , i.e. calculate the eigenvalues and eigenvectors to diagonalize it:  $\mathbf{A} = \mathbf{V}\mathbf{D}\mathbf{V}^{-1}$ . The time constants of the linearized system in the orthogonal directions are the inverse of the purely real eigenvalues contained in  $\mathbf{D}$ :

$$\mathbf{D} = \begin{pmatrix} -1/\tau_{0,\perp} & 0 \\ 0 & -1/\tau_{0,\tilde{v}} \end{pmatrix}. \quad (9)$$

The negative sign of the eigenvalues indicates the stability, attractiveness of the steady state  $\mathbf{v}_0$ . For the case illustrated throughout the text, we find  $\tau_{0,\perp} \approx 10$  ns much shorter than  $\tau_{0,\tilde{v}} \approx 70$  ns. Last but not least, we find that the eigenvector associated to the eigenvalue  $-1/\tau_{0,\tilde{v}}$  (slow time constant) closely matches the direction of the straight line connecting  $(X_0, Y_0)$  and  $(X_M, Y_M)$  whose unit vector is

$$\tilde{\mathbf{v}} = \begin{pmatrix} X_M - X_0 & Y_M - Y_0 \\ \Delta\tilde{v} & \Delta\tilde{v} \end{pmatrix}^T, \quad (10)$$

with

$$\begin{aligned} \Delta\tilde{v} &= \sqrt{(X_M - X_0)^2 + (Y_0 - Y_M)^2} \\ &= \sqrt{\Delta X^2 + \Delta Y^2}. \end{aligned} \quad (11)$$

We say that the eigenvectors span the stable linear space, which is locally tangent to the manifolds of the steady state [40].

A similar analysis near the unstable point leads to the same conclusion, except that the eigenvalue associated to  $\tilde{\mathbf{v}}$  is *positive*:  $+1/\tau_{M,\tilde{v}}$ , indicating the repulsiveness of this steady state along its unstable manifold. In the intermediate region between  $(X_0, Y_0)$  and  $(X_M, Y_M)$ , the magnitudes of the drift field arrows (Figure 5) makes the time-scale separation of the slow dynamics along  $\tilde{\mathbf{v}}$  and the fast one along the orthogonal directions even more valid.

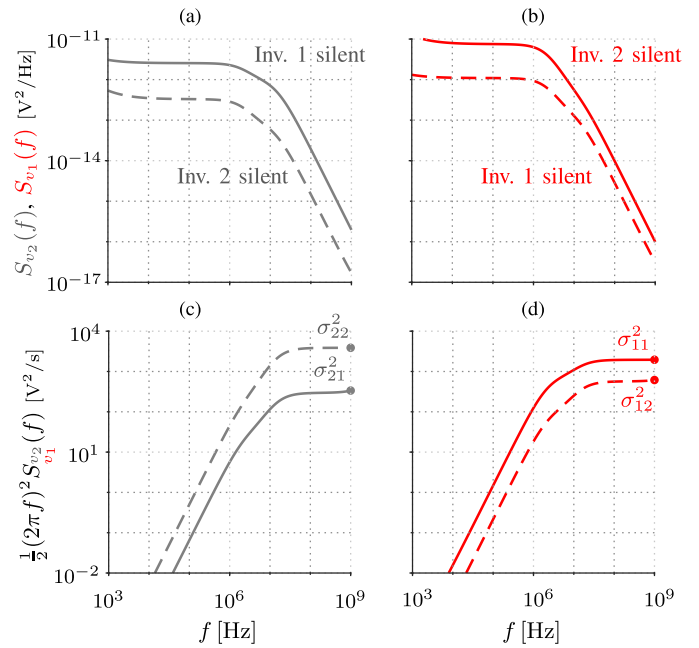


Fig. 6. Power spectral densities of the node voltages (a)  $v_2$  (gray) and (b)  $v_1$  (red) obtained from NOISE(AC) simulations of the circuit of Figure 2(a), here around the stable steady state  $(v_2, v_1) = (X_0, Y_0)$ . The individual contribution of each inverter (plus the access transistor connected to its output) is extracted separately by disabling the noise (NONOISE command in SPICE) of the other inverter-transistor pair (then said silent). For a given node (e.g.  $v_2$  in (a)), they are thus two configurations: in solid line, the dominant noise contribution from the *driving* inverter (e.g. Inverter 2); in dashed line, the smaller (yet non negligible) contribution of the *load* inverter (e.g. Inverter 1). Illustrated case: same as Figure 3. (c) and (d) Characterization of  $\sigma(X_0, Y_0)$  through the separate extraction of the four  $\sigma_{ij}^2$ :  $\sigma_{22}^2 = 3872 \text{ V}^2 \text{ s}^{-1}$ ;  $\sigma_{21}^2 = 336 \text{ V}^2 \text{ s}^{-1}$ ;  $\sigma_{11}^2 = 1957 \text{ V}^2 \text{ s}^{-1}$ ;  $\sigma_{12}^2 = 614 \text{ V}^2 \text{ s}^{-1}$ . Similar simulations were performed around the *unstable* steady state to get  $\sigma(X_M, Y_M)$  (not shown):  $\sigma_{22}^2 = 1705 \text{ V}^2 \text{ s}^{-1}$ ;  $\sigma_{21}^2 = 271 \text{ V}^2 \text{ s}^{-1}$ ;  $\sigma_{11}^2 = 1320 \text{ V}^2 \text{ s}^{-1}$ ;  $\sigma_{12}^2 = 301 \text{ V}^2 \text{ s}^{-1}$ . Extracted infinitesimal variances of 1D white noise of (19) at steady states:  $\sigma_0^2 = 910 \text{ V}^2 \text{ s}^{-1}$  (stable) and  $\sigma_M^2 = 565 \text{ V}^2 \text{ s}^{-1}$  (unstable).

While the two-dimensional drift was extracted and depicted in Figure 5(b) for illustrative purposes, as well as to validate the hypothesis of time-scale separation and unidimensional dynamics, it will not be used to predict the *MTTF*. Instead, we will rely on the reduced unidimensional model presented in Section IV-B.

4) *SPICE Characterization of the Noise*: We now explain how to characterise  $\sigma(\mathbf{v})$  in the noise term of the SDE (6). First of all, let us emphasize that the noise can only be inferred, from fluctuations of the observables  $v_2$  and  $v_1$  at the steady states of the circuit, i.e. not at any arbitrary  $(v_2, v_1)$  of the state space. This problem was generally referred to as “hidden stochasticity” in [25], as encountered in many physical systems. Our goal is thus to extract  $\sigma(X_0, Y_0)$  and  $\sigma(X_M, Y_M)$ , i.e. four quantities for each steady state (either 0 or M):

$$\sigma \equiv \begin{pmatrix} \sigma_{22} & \sigma_{21} \\ \sigma_{12} & \sigma_{11} \end{pmatrix}. \quad (12)$$

From (6) we develop, for instance, the equation of  $dv_2/dt$ :

$$\frac{dv_2}{dt} = h_2(v_2, v_1) + \sigma_{22}w_2(t) + \sigma_{21}w_1(t). \quad (13)$$

Equation (13) clearly shows that  $v_2(t)$  receives two independent noise contributions: the dominant  $\sigma_{22}w_2(t)$  from its

driving Inverter 2; the smaller  $\sigma_{21}w_1(t)$  from the load Inverter 1. An important ingredient is that we are going to extract  $\sigma_{22}$  and  $\sigma_{21}$  separately from two different SPICE simulations by disabling the noise of the other inverter (NONOISE command in SPICE). For instance, if Inverter 1 (as well as the access transistor connected to its output) is silent, (13) becomes

$$\frac{dv_2}{dt} = h_2(v_2, v_1) + \sigma_{22}w_2(t), \quad (14)$$

i.e. reduces to a scalar nonlinear Langevin equation with one single white noise.

Previous works [8], [9] attempted to subsequently extract the infinitesimal variance of the white noise ( $\sigma_{22}^2$  in (14)) by assimilating the SRAM bitcell to a linear  $RC$  circuit near the steady state. Under this single-pole assumption,  $\sigma_{22}^2$  relates to the *integrated* voltage noise power

$$\sigma_{v_2}^2 = \int_0^\infty S_{v_2}(f) df, \quad (15)$$

according to [9]:

$$\sigma_{22}^2 = 4\pi f_{p,22} \sigma_{v_2}^2 \quad (16)$$

where  $f_{p,22}$  would be the fitted value of the only presumed dominant pole of  $S_{v_2}(f)$ . In passing, we would like to point out that, for device modeling and SPICE simulations, PSD like  $S_{v_2}(f)$  are, by convention, *one-sided*, i.e. only defined and integrated over positive frequencies to retrieve the noise power as in (15). At first sight of the voltage noise PSD extracted from NOISE(AC) simulations (Figures 6(a) and 6(b)), the  $RC$  low-pass-filter assumption, whose signature is a first-order transfer function with a dominant pole, seems to be fairly well-founded. However, the method (16) has turned out to be very sensitive to slight perturbations of the PSD attributed to higher-order poles and zeros introduced by the various capacitances of the SRAM bitcell. The usage of (16) should thus be avoided.

Fortunately, it is possible to directly relate  $\sigma_{22}^2$  to the high-frequency behavior of the PSD  $S_{v_2}(f)$ , as explained below:

$$\sigma_{22}^2 = \frac{1}{2}(2\pi f^*)^2 S_{v_2}(f^*) \quad (\text{Inv. 1 silent}). \quad (17)$$

The  $f^*$  selected for the extraction is a sufficiently high frequency where  $f^2 S_{v_2}(f)$  (corresponding, within constants, to the one-sided PSD of the output current noise) is nearly flat (e.g. 1 GHz in Figures 6(c) and 6(d)). Equation (17) is trivial for an  $RC$  circuit, and can be justified to be valid more generally.

The key ingredient is to relate  $S_{v_2}(f)$ , the PSD of  $v_2(t)$ , to the one-sided PSD of the white noise  $\sigma_{22}w_2(t)$ , which is  $2\sigma_{22}^2$ . Near the steady state,  $v_2(t)$  may be regarded as a first-order Markov process resulting from the filtering of the white noise  $\sigma_{22}w_2(t)$  by the system (13) (yet with  $h_2(v_2, v_1)$  linearized). The PSD is then given by [41, Section II-D, eq. (34)]. For a high frequency beyond the dominant pole of the linearised system, i.e.  $f^* \gg f_{p,22}$ ,  $S_{v_2}(f^*)$  converges to the PSD of the Wiener process  $W_2(t) = \int_0^t \sigma_{22}w_2(t) dt$ , which can be shown to be  $(2\sigma_{22}^2)/(2\pi f^*)^2$  (see [41, eq. (36)] or [42, eq. (7)]). Isolating  $\sigma_{22}^2$  finally leads to (17).

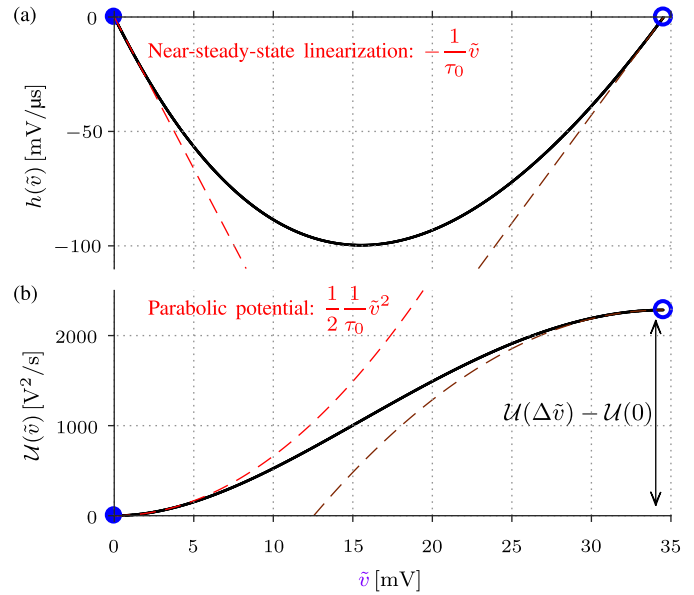


Fig. 7. (a) Extracted deterministic drift as appears in (19), which derives from (b) quasi potential  $\mathcal{U}(\tilde{v}) = -\int_0^{\tilde{v}} h(\tilde{v}') d\tilde{v}'$ . The near-stable-steady-state ( $(X_0, Y_0)$ , full blue dot) approximations inherent to [23] and [26]'s formulas are shown (dashed red line). Eyring-Kramers formula also exploits the behavior near the unstable point ( $(X_M, Y_M)$ , open blue dot and dashed brown curve). Illustrated case: same as Figure 3.  $\Delta\tilde{v} = 34.5$  mV.

Intuitively, in high frequency, the dynamics  $h_2(v_2, v_1)$  is ineffective in varying  $v_2(t)$  compared to the white noise, whose intensity is thereby contained in the tail of  $S_{v_2}(f)$ . The  $(2\pi f^*)^2$  factor in (17) results from the integral relationship between  $v_2(t)$  and  $\sigma_{22}w_2(t)$ .

The three other  $\sigma_{ij}^2$  are extracted similarly, as illustrated in Figures 6(c) and 6(d) (the numerical values both at the stable and unstable steady states are provided in the caption). This procedure to characterise  $\sigma(X_0, Y_0)$  and  $\sigma(X_M, Y_M)$  is fundamental in the *MTTF* prediction methodology, since those quantities will come into play in the closed-form analytical formulas.

## B. Reduced Unidimensional Stochastic Model

Upon observation of transient experiments like Figure 3 (other trajectories simulated for other cases showed similar behavior) and following the argument of time-scale separation supported by the previous section (Figure 5), it seems reasonable to reduce the dimensionality of the system (4). To this end, we introduce an unidimensional (1D) coordinate  $\tilde{v}$  (previously shown in violet in Figures 3(b) and 5), constructed by affine transformation of  $(v_2, v_1)$  obtained by orthogonal projection of the 2D state vector  $\mathbf{v}$  on the  $\tilde{\mathbf{v}}$  defined in (10):

$$\begin{aligned} \tilde{v} &= \tilde{\mathbf{v}}^\top \cdot \mathbf{v} \\ &\equiv \frac{X_M - X_0}{\Delta\tilde{v}} \cdot v_2 + \frac{Y_M - Y_0}{\Delta\tilde{v}} \cdot v_1, \end{aligned} \quad (18)$$

where  $Y_M - Y_0 < 0$  and  $\Delta\tilde{v}$  is the Euclidean distance between  $(X_0, Y_0)$  and  $(X_M, Y_M)$ , as defined earlier in (11).

This is equivalent to studying the nonlinear SRAM bitcell dynamics in the main direction  $\tilde{\mathbf{v}}$  dominating the *TTF*,

modelled by the *scalar* Langevin equation, assuming a first-order dynamics [9]:

$$\frac{d\tilde{v}}{dt} = h(\tilde{v}) + \sigma(\tilde{v})w(t). \quad (19)$$

Equation (19) may be thought as formally describing a *non-linear RC* circuit, i.e. an overdamped single-state system with drift-diffusion dynamics [25]. We refer to (19) to as the *unidimensional stochastic model* of the SRAM bitcell [9], as a special case of single-state nonlinear bistable system [25]. Below, we explain how  $h(\tilde{v})$  and  $\sigma$  are characterized from the SPICE simulations presented in Section IV-A.

1) *Characterization of  $h(\tilde{v})$* : The function  $h(\tilde{v})$  (in  $\text{V s}^{-1}$ ), determining the natural dynamics of the 1D system in absence of noise, absorbs the nonlinearities of both the resistive and capacitive components of the SRAM bitcell. It can be cheaply and unambiguously extracted from a noiseless transient simulation (TRAN in SPICE, similarly to its 2D field counterpart in Section IV-A). The procedure goes as follows [9]: 1) starting from an initial condition  $(v_2(0), v_1(0)) = (X_M - \epsilon, Y_M + \epsilon)$ ; the deterministic evolution of  $(v_2(t), v_1(t))$  toward  $(X_0, Y_0)$  is recorded; 2)  $\tilde{v}(t)$  is calculated through (18); 3)  $d\tilde{v}/dt$  is computed numerically and mapped to  $\tilde{v}(t)$  to provide  $h(\tilde{v})$  between 0 and  $\Delta\tilde{v}$  (depicted in Figure 7(a)). Again, this extraction is nothing but a special case, one single trajectory of Figure 5(b) originating from  $(X_M - \epsilon, Y_M + \epsilon)$ . In 1D, drift  $h(\tilde{v})$  may always be thought as deriving from a scalar *quasi potential*  $\mathcal{U}(\tilde{v})$  [39] (extracted and represented on  $[0, \Delta\tilde{v}]$  in Figure 7(b)):

$$h(\tilde{v}) \equiv -\frac{d\mathcal{U}}{d\tilde{v}} \iff \mathcal{U}(\tilde{v}) - \mathcal{U}(0) = -\int_0^{\tilde{v}} h(\tilde{v}') d\tilde{v}'. \quad (20)$$

The stable steady states (notably the fragile  $\tilde{v} = 0$ ) corresponds to the valleys of  $\mathcal{U}(\tilde{v})$ , whereas the hill characterises the unstable point ( $\tilde{v} = \Delta\tilde{v}$ , labelled M). The quasi potential landscape directly relates to the steady-state occupation probability (e.g. [20], [21]) through a Boltzmann relation.

2) *Characterization of  $\sigma(\tilde{v})$* : In (19),  $\sigma(\tilde{v})w(t)$  is the thermal noise term,  $\sigma^2(\tilde{v})$  being the intensity, or infinitesimal variance, or variance per unit time (i.e. in  $\text{V}^2 \text{s}^{-1}$ ) and  $w(t)$  the white Gaussian noise process (in  $\text{s}^{-1/2}$ ) [9] of unit two-sided PSD (i.e. the one-sided PSD of  $w(t)$  is 2, dimensionless). The meaning to be attributed to the notion of “infinitesimal variance” is the following:  $\text{Var}\{\int_0^t \sigma w(t) dt\} = \sigma^2 t$ , i.e.  $\text{Var}\{\int_0^t \sigma w(t) dt\}$  is proportional to the time window. An example is the variance of a white current noise (e.g. physically generated within a CMOS inverter) integrated on an lossless capacitance [43].

As mentioned in Section IV-A, the noise can only be inferred, in our setup, at the steady states of the circuit. Consequently,  $\sigma(\tilde{v})$  is, at best, known in  $\tilde{v} = 0$  and  $\tilde{v} = \Delta\tilde{v}$ , where we respectively denote it  $\sigma_0$  and  $\sigma_M$ . Most previous analytical formulas coarsely assumes that  $\sigma^2(\tilde{v})$  is *constant*, i.e. that it does *not* vary with  $\tilde{v}$  throughout the bit flip (e.g. assumed equals to  $\sigma_0^2$ ). Finer prediction would rely on the knowledge of both  $\sigma_0^2$  and  $\sigma_M^2$  as will be reviewed in Section V.

The  $\sigma$  (evaluated at either steady states) of (19) relates to the matrix  $\sigma$  of (6), whose four entries have been extracted from

NOISE (AC) simulations according to Figure 6. To establish the link, we first note from (6) and (18) that

$$\begin{aligned} \frac{d\tilde{v}}{dt} &= \frac{d(\tilde{v}^\top \cdot \mathbf{v})}{dt} \\ &= \tilde{v}^\top \cdot \frac{d\mathbf{v}}{dt} \\ &= \tilde{v}^\top \cdot \mathbf{h}(\mathbf{v}) + \tilde{v}^\top \sigma \mathbf{w}(t). \end{aligned} \quad (21)$$

By identification with (19), we find

$$\sigma w(t) = \tilde{v}^\top \sigma(\mathbf{v}) \mathbf{w}(t), \quad (22)$$

or, written in terms of white noise variance,

$$\begin{aligned} \sigma^2 &= \tilde{v}^\top \sigma \sigma^\top \tilde{v} \\ &= \begin{pmatrix} X_M - X_0 & Y_M - Y_0 \\ \Delta\tilde{v} & \Delta\tilde{v} \end{pmatrix} \begin{pmatrix} \sigma_{22} & \sigma_{21} \\ \sigma_{12} & \sigma_{11} \end{pmatrix} \begin{pmatrix} \sigma_{22} & \sigma_{12} \\ \sigma_{21} & \sigma_{11} \end{pmatrix} \begin{pmatrix} X_M - X_0 \\ \Delta\tilde{v} \\ Y_M - Y_0 \\ \Delta\tilde{v} \end{pmatrix}. \end{aligned} \quad (23)$$

Equation (23) is used to calculate  $\sigma_0^2$  and  $\sigma_M^2$  from the previously extracted quantities.

## V. APPROXIMATE CLOSED-FORM PREDICTION FORMULAS

Now characterized, the unidimensional stochastic model (19) points to the hope of analytically predicting the *MTTF*. There are, however, two obstacles that should not be overlooked: (i) the SDE (19) is nonlinear through  $h(\tilde{v})$  (Figure 7(a)), and any attempt of linearization is expected to result in significant discrepancies, as will be evidenced; (ii) even if the parameters of (19) have been accurately characterized, including the noise, deducing a (semi-)analytical general formula for the *MTTF* from (19) is not a straightforward mathematical task. We will therefore draw on literature from various scientific fields.

Let us first mention our preliminary work [9]. A partially empirical estimate of the *MTTF* was obtained by efficiently simulating trajectories of  $\tilde{v}(t)$  from the SDE (19), in a Monte-Carlo fashion. *Euler-Maruyama method* [44], a dedicated numerical integration scheme, was used. For each  $\tilde{v}(t)$  trace, the *TTF* corresponds to twice the first time to reach  $\Delta\tilde{v}$ , since at the top of the hill (Figure 7(b)) the state can still flip left or right with probability 1/2. Although attractive in CPU time (reduced to barely a few minutes compared to the three days of transient noise simulations in SPICE), the accuracy of this attempt was quite low due to the incorrect constant- $\sigma$  assumption. Moreover, such empirical approach, based on repeated trials, does not offer an insightful closed-form formula for the *MTTF*.

### A. Near-Stable-Steady-State Approximate Formulas

Our proceedings [8], [9] already pointed out the severe inaccuracy of some analytical formulas [23], [26] that rely on a linearization of the SRAM bitcell dynamics,  $h(\tilde{v})$  in (19). We review them in the present section.

1) *First-Passage Time of an Ornstein-Uhlenbeck Process*: Translating the definition of Section III-A in 1D, the *TTF* as the time taken by  $\tilde{v}(t)$  to, starting from 0, exceed  $\Delta\tilde{v}$  for the last time before successfully transitioning to the other stable point. The mean *TTF* (*MTTF*) is twice the mean *first*

passage time (FPT), which is the mean time to reach  $\Delta\tilde{v}$  for the *first* time starting from 0 [25]; the factor 2 accounts for the probability 1/2 of falling left or right when reaching the unstable point at  $\Delta\tilde{v}$ .

A closed-form solution of such FPT problem exists, unfortunately only for the special case of linearized drift term

$$h(\tilde{v}) \approx -\frac{1}{\tau_0} \tilde{v}(t) \quad (24)$$

(dashed red line in Figure 7(a)), with

$$\frac{1}{\tau_0} = -\frac{dh}{d\tilde{v}}(0) = \frac{d^2\mathcal{U}}{d\tilde{v}^2}(0), \quad (25)$$

the time constant of the 1D system linearized at  $\tilde{v} = 0$ . The  $\tilde{v}$  defined by (19) and (24) is called an *Ornstein-Uhlenbeck process*. By construction, the  $\tau_0$  defined in (25) is the  $\tau_{0,\tilde{v}}$  found in (9) when searching for the eigenvalues of the Jacobian matrix of the drift field of the 2D system.

Nobile [26] has rigorously solved the FPT problem of an Ornstein-Uhlenbeck process, leading to [26, (6a)]:

$$MTTF \approx 2\tau_0 \left( \sqrt{\pi} \int_0^{\Delta\tilde{v}/(\sigma_0\sqrt{\tau_0})} du \exp(u^2) + \int_0^{\Delta\tilde{v}/(\sigma_0\sqrt{\tau_0})} du \exp(u^2) \operatorname{erf}(u) \right). \quad (26)$$

2) *Kish's Formula*: Kish [23] proposed a simplified Rice formula for the mean frequency of crossing ( $1/MTTF$  in our notations) a given threshold voltage ( $\Delta\tilde{v}$ ) by a Gaussian noise process (as  $\tilde{v}(t)$  is roughly assumed) [23, (8)]. Kish's formula in integral form [23, (8)] diverges when applied to the PSD of the output voltage noise of an inverter (see, for instance, Figures 6(a) and 6(b)). It is most often used (notably [24, (4)]) in a simplified form [23, (9)] supposing band ( $f_p = 1/(2\pi\tau_0)$ )-limited white (thermal) noise, written with the notations of this paper as:

$$\frac{1}{MTTF} = \frac{2}{\sqrt{3}} \exp\left(-\frac{1}{2}\left(\frac{\Delta\tilde{v}}{\sigma_{\tilde{v}}}\right)^2\right) f_p \propto \exp\left(-\frac{\Delta\tilde{v}^2/(2\tau_0)}{\sigma_{\tilde{v}}^2/\tau_0}\right) \frac{1}{\tau_0}. \quad (27)$$

Despite lack of detailed proof, we understand (27) as linearizing the true SRAM bitcell dynamics around the stable steady state to reduce it to an *RC*-like circuit with Gaussian voltage distribution. It can be regarded as a simplified version of (26) [25].

Within the exponential,  $\Delta\tilde{v}^2/(2\tau_0)$  is the value of the quasi-potential barrier evaluated at the unstable point ( $\tilde{v} = \Delta\tilde{v}$ ) under the coarse harmonic (parabolic) potential approximation (dashed red line in Figure 7(b)), equivalent to linearized drift (24). Remembering that for an *RC* circuit we have  $\tau_0 = RC$  and  $\sigma_{\tilde{v}}^2 = kT/C$ , (27) finally highlights a Maxwell-Boltzmann probability [9]:

$$1/MTTF \propto \exp(-\Delta E/kT)/\tau_0, \text{ with } \Delta E = C\Delta\tilde{v}^2/2.$$

## B. Eyring-Kramers Formulas

The calculation of transition rates ( $1/MTTF$ ) is a classical problem in chemical physics. The old Eyring-Kramers formula [45] is valid for a wide class of nonlinear bistable systems but requires a constant white noise intensity. Our recently published extended formula [25] overcomes this limitation.

1) *Classical Eyring-Kramers Formula: Constant  $\sigma^2$* : The near-stable-steady-state approximation inherent to [23] and [26] is twofold: the deterministic drift is linearized around  $\tilde{v} = 0$  only; the noise is assumed constant and also extracted at  $\tilde{v} = 0$  only. As shown numerically in [25], drastic accuracy improvement is achieved by Eyring-Kramers formula [45], revisited in [39] and applied to the SRAM bitcell model (19) in [25]:

$$MTTF \approx 2\pi\sqrt{\tau_0\tau_M} \exp\left(\frac{\mathcal{U}(\Delta\tilde{v}) - \mathcal{U}(0)}{\frac{1}{2}\sigma^2}\right). \quad (28)$$

Equation (28) also takes into account the drift (quasi-potential) behavior of the system near the *unstable* point (dashed brown lines in Figure 7).

We explain the newly introduced quantities in (28).  $\mathcal{U}(\Delta\tilde{v}) - \mathcal{U}(0)$  is the *true* quasi-potential barrier (computed according to (20) and indicated in Figure 7(b)) whose crossing by the random diffusion process leads to a bit flip.

$$\frac{1}{\tau_M} = \frac{dh}{d\tilde{v}}(\Delta\tilde{v}) = \left| \frac{d^2\mathcal{U}}{d\tilde{v}^2}(\Delta\tilde{v}) \right| \quad (29)$$

is the time constant of the system linearized at the unstable (and repulsive) point ( $\tilde{v} = \Delta\tilde{v}$ ), straightforwardly computed from either  $h(\tilde{v})$  or  $\mathcal{U}(\tilde{v})$ . Hence, a new effective time constant of the diffusion process, defined as a geometrical mean  $\tau \equiv \sqrt{\tau_0\tau_M}$ , appears in the pre-factor of (28). It somehow incorporates the drift behavior in both the near stable- and unstable-steady-state regions.

Unfortunately, the classical formula (28) still assumes constant noise variance  $\sigma^2$ . The numerical values, for instance those provided for the illustrated case in the caption of Figure 6, show that  $\sigma_0$  can be significantly different from  $\sigma_M$ , i.e. that the noise intensity *does* significantly vary along the bit-flip trajectory. This behavior, for nonlinear devices, was expected from physical considerations [34]. No observation or theoretical argument justifies favouring either  $\sigma = \sigma_0$  or  $\sigma = \sigma_M$  for our purposes. Thus, these two exclusive choices could be inaccurate, when attempting to apply (28) to predict the *MTTF* in SRAM bitcells.

2) *Extended Eyring-Kramers Formula:  $\sigma_0$  and  $\sigma_M$* : In [25], we have addressed the situation of “hidden stochasticity”, i.e. when  $\sigma(\tilde{v})$  is only known in 0 and  $\Delta\tilde{v}$  and hidden outside the steady states. The main result is

$$MTTF \approx 2\pi\sqrt{\tau_0\tau_M} \frac{\sigma_0}{\sigma_M} \exp\left(\frac{\mathcal{U}(\Delta\tilde{v})}{\frac{1}{2}\sigma_M^2}\right) \exp\left(-2\left(\frac{1}{\sigma_M^2} - \frac{1}{\sigma_0^2}\right)\bar{\mathcal{U}}\right), \quad (30)$$

where

$$\bar{\mathcal{U}} \equiv \frac{1}{\Delta\tilde{v}} \int_0^{\Delta\tilde{v}} \mathcal{U}(\tilde{v}') d\tilde{v}'. \quad (31)$$

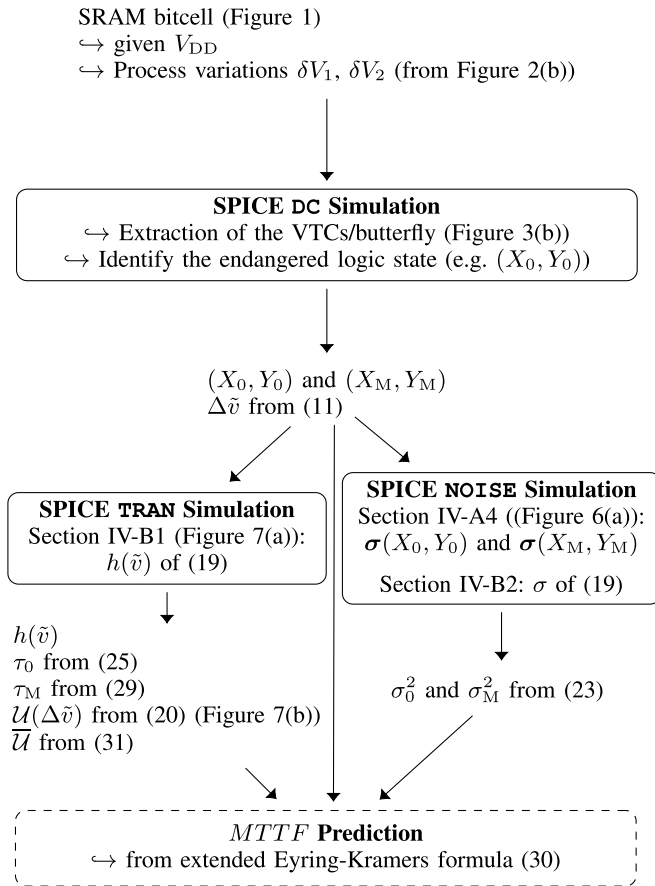


Fig. 8. Flow chart of the proposed methodology, aimed at predicting the mean time to failure due to the noise in ULV SRAM bitcells affected by process variations (assumed given, as selected from Figure 2(b)).

Equation (30) does incorporate the noise behavior near both the stable ( $\sigma_0$ ) and the unstable ( $\sigma_M$ ) steady states. It is somewhat similar to the classical formula (28) where  $\sigma = \sigma_M$  would be used, yet with additional factors:

- $\sigma_0/\sigma_M$  naturally appears following Itô's rule for stochastic calculus [25]. It is expected to have a negligible impact on the order of magnitude of the  $MTTF$ , compared to the exponentials.
- The factor

$$\exp\left(-2\left(\frac{1}{\sigma_M^2} - \frac{1}{\sigma_0^2}\right)\bar{U}\right) \quad (32)$$

may be regarded as correcting for the fact that the noise variance is not constant throughout the state flip. It is unity only when  $\sigma(\tilde{v}) = \sigma_0 = \sigma_M = \text{constant}$ . If  $\sigma_M < \sigma_0$ , the argument within the exponential is *positive* and the factor is larger than 1, thereby compensating the excessive first exponential involving a too small  $\sigma$ . Conversely, if  $\sigma_M > \sigma_0$ , the correcting factor is smaller than 1.

The complete methodology, aimed at predicting the  $MTTF$  in a given SRAM bitcell at a given  $V_{DD}$  affected by process variations, from the characterization of the stochastic model based on SPICE simulations to the extractions of the different quantities involved in the analytical extended Eyring-Kramers formula (30), has been summarized as a flow chart in Figure 8.

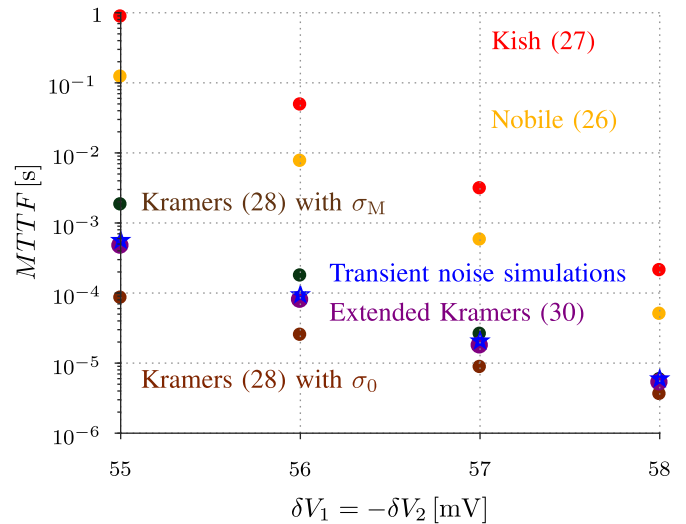


Fig. 9.  $MTTF$  empirically estimated from transient noise simulations (averaged over 1000 experiments like Figure 3(a), for each point) compared to the predictions of the analytical formulas.

## VI. PREDICTION OF THE $MTTF$ : RESULTS AND DISCUSSION

In Figure 9, we assess the accuracy of the different closed-form formulas for the  $MTTF$ , taking the massive and finely-tuned transient noise simulations of Section III as reference golden values. We exploit the unidimensional stochastic model (19) of the SRAM bitcell to insightfully point out and explain the origins of the discrepancies.

Reference values for the  $MTTF$  were obtained by averaging 1000  $TTF$  (which leads to histograms like Figure 4), extracted from SPICE transient noise simulations like Figure 3(a) [8] for several severe process variations  $\delta V_1 = -\delta V_2 = 55$  to  $58$  mV (blue pentagams in Figure 9). As previously observed in [7], the metric spans across orders of magnitude: it drops from half a ms (as provided earlier in Figure 4), at  $\delta V_1 = -\delta V_2 = 55$  mV to a only few  $\mu\text{s}$  at  $58$  mV. This exponential trend has been explained earlier by the reduction of the  $SNM$  with  $\delta V$ , from  $5$  mV to  $1$  mV [8], and could have been anticipated from the various approximate formulas such as (27) or (28).

The low reported  $MTTF$  values confirm that, while they were considered functional at time zero ( $SNM > 0$ ), all these bitcells weakened by static variations are prone to dynamic instability and should be classified as defective when the typical retention time of the SRAM is for example longer than  $1$  ms in the ULP system application. An extrapolation of the robust (as validated with transient noise simulations) predictions (30) of Figure 9 to smaller process variations, e.g.  $\delta V_1 = -\delta V_2 = 50$  mV corresponding to an  $SNM = 10$  mV, estimates  $MTTF$  greater than  $1 - 10$  s. Because this value is larger than any practical retention time, it justifies *a posteriori* the choice of  $SNM = 10$  mV as first guess to define the boundary of the orange crown in Figure 2(b). Similarly, no bit flip would ever be observed or practically measured on silicon in SRAM bitcells in conditions closer to nominal (e.g.  $V_{DD} = 1$  V).

We first review the predictions of (26) and (27), respectively depicted in red and orange in Figure 9. As extensively discussed in previous publications [8], [9], [25], they totally fail in accurately predicting the  $MTTF$ , the discrepancy reaching two to three orders of magnitude for larger  $MTTF$ . This comes from the near-stable-steady-state linearization from which these formulas derive. In particular, the approximation (24) is inappropriate in describing the nonlinear SRAM dynamics (Figure 7(a)). Ornstein–Uhlenbeck model assumes a linear drift term  $-\tilde{v}/\tau_0$  all along the trajectory and thereby severely overestimates the recall effect to  $\tilde{v} = 0$ . In particular, it gives non-zero drift term  $-\Delta\tilde{v}/\tau_0$  at  $\tilde{v} = \Delta\tilde{v}$  while it is exactly zero within the full nonlinear model (19) (see Figure 7(a)). Equivalently, through the parabolic approximation, Kish overestimates the quasi-potential barrier that the process  $\tilde{v}(t)$  must cross Figure 7(b):

$$\frac{1}{2} \frac{1}{\tau_0} \Delta\tilde{v}^2 \gg \mathcal{U}(\Delta\tilde{v}) - \mathcal{U}(0). \quad (33)$$

This clearly questions the failure rate predictions of [24], based on Kish formula.

The major improvement brought by the different Eyring–Kramers formula of Section V-B is the careful treatment of the drift  $h(\tilde{v})$ . The classical formula (28) requires one single constant noise variance  $\sigma^2$ . Depending on whether  $\sigma_0$  (light brown in Figure 9) or  $\sigma_M$  (dark brown in Figure 9) is used, the noise is either over- or under-estimated, causing the  $MTTF$  to be either under- or over-estimated compared to transient noise simulations. Interestingly, we can observe in Figure 9 that the gap between the  $\sigma_0$ - and  $\sigma_M$ -based predictions widens for the case of more moderate process variations, i.e. the variations of  $\sigma^2(\tilde{v})$  with the state of the SRAM bitcell becomes more significant. This is because the steady states  $(X_0, Y_0)$  and  $(X_M, Y_M)$  becomes further apart (larger  $\Delta\tilde{v}$  range), so that the influence of the change in bias point from 0 to M gets substantial.

This is why we recommend harnessing the extended law (30) to predict the  $MTTF$  in SRAM bitcells with much greater accuracy. It was indeed constructed to remedy these important shortcomings of the former analytical approaches [25]. It achieves, at least for the investigated cases, a remarkable accuracy: compared to SPICE transient noise simulations the error remains below 20%, which is outstanding for a metric spanning across orders of magnitude. This combines with a major reduction of the CPU time: from three days (Section III) to a few minutes for four  $(\delta V_1, \delta V_2)$  cases, accounting for the cheap deterministic SPICE simulations required to calibrate the stochastic model and to apply the closed-form formula for the  $MTTF$ . We then estimate to two days the time required to estimate the  $MTTF$  of all the cases in the orange crown of Figure 2(b). A benchmark with the few previous accelerated simulation frameworks [18], [19], [20], [21] is complicated for two reasons: the authors did not report the CPU time; more importantly, the extracted  $TTF$  was never compared to reliable reference values as provided by general SPICE transient noise simulations in our work.

## VII. CONCLUSION AND PERSPECTIVES

ULV SRAM arrays are essential blocks of ULP systems. The data retention is threatened by two random phenomena affecting the MOS transistors and thus the SRAM bitcell functionality: static process variations and dynamic intrinsic noise. Whereas most simulation and modeling efforts have been rightly focused on variability, we have shown that, because the noise immunity of the bitcells severely degrades with large process variations, dynamic instability comes as a non-negligible additional concern when the typical retention time is long. An efficient variability-aware noise simulation framework, compatible with industrial SPICE tools and compact models, is therefore needed. We have exploited a 2D variability representation, mapping of the situation at time zero, to select cases to be treated in priority for noise analysis.

Because the brute-force approach that would combine Monte-Carlo simulations with transient noise analyses is unaffordable in CPU time, we have developed and presented an hybrid semi-analytical methodology aimed at accurately predicting the  $MTTF$ , compatible with industrial transistor compact models and simulation tools. The different steps are summarized in Figure 8. SRAM bitcells in retention are autonomous stochastic nonlinear dynamical systems, for which stochastic model faithful to its strongly nonlinear behavior accounting for varying white noise intensity can be fully characterized from a limited number of fast conventional SPICE simulations. This allows to finally apply the extended Eyring–Kramers formula to estimate the  $MTTF$  with a relative error 20%, remarkably.

As a perspective, we should mention that, toward comprehensive reliability assessment, the contribution of the low-frequency noise (which includes both  $1/f$  noise and random telegraph noise [46], [47]), in addition to process variations and thermal noise, remains to be investigated. The  $1/f$  noise, yet present in our transient noise simulations, was negligible in the bandwidth of interest. The  $1/f$  corner can indeed be discretely noticed near 1 kHz in Figures 6(a) and 6(b). This is because, in this work, the PSDs of the noise are evaluated in nominal conditions, i.e. ignoring the device-to-device variability of the statistics of the low-frequency noise itself [46], [47]. The effect of the *average*  $1/f$  turns out to be negligible compared to the thermal noise in the simulated noise bandwidth. This conclusion is very likely to be revised by considering the variations of the  $1/f$  (e.g. at 3 or even  $6\sigma$  as made in [47] when studying analog circuits like comparators and oscillators). Thus, in a longer-term perspective, the stochastic model and analytical prediction tools will have to be enriched with colored and non-Gaussian noise sources. By providing a quantitative answer to the timely scientific question of whether the intrinsic noise sources substantially inflate the SRAM cell failure probability, optimal ULV design margins (i.e. lowering the supply voltage below the 300 mV limits reported in [2]) can be achieved.

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